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PATENT Atty. Dkt. No. AMAT/5619/DSM/LOW K/JW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Nguyen, et al.

Serial No.: 09/912,103

Confirmation No.: 4476

Filed: July 23, 2001

For: Selective Etching of

> Organosilicate Films Over Silicon Oxide Stop Etch Layers

MAIL STOP Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

തയയയയയയയയയയയ Group Art Unit: 2823

Examiner: Khiem D. Nguyen

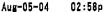
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Sianature

RESPONSE TO OFFICE ACTION DATED JULY 2, 2003

In response to the Office Action dated July 2, 2003, having a shortened statutory period for response set to expire on October 2, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5619/BTP, the fee of \$72.00 for four additional dependent claims, and any other fees, including extension of time fees, required to make this Response timely and acceptable to the Office.



02:58pm

From-Moser, Patterson & Sheridan L.L.P.

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DATE:

August 5, 2004

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AMAT/5619/DSM/LOW K/JW

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Keith M. Tackett

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ORIGINAL TO

FOLLOW?

☐ YES ⊠ NO

MESSAGE: Attached are copies of the Response to Office Action dated July 2, 2003; Facsimile Cover Sheet; and Confirmation Facsimile Transmittal filed on October 2, 2003, which was faxed to the designated fax number 703-746-9179 from the Office Action dated February 14, 2003.

RESPONSE TO OFFICE ACTION DATED JULY 2, 2003

TITLE:

SELECTIVE ETCHING OF ORGANOSILICATE FILMS OVER

SILICON OXIDE STOP ETCH LAYERS

U.S. SERIAL NO.:

09/912,103

FILING DATE:

JULY 23, 2001

INVENTOR:

NGUYEN, ET AL.

EXAMINER:

KHIEM D. NGUYEN

GROUP ART UNIT:

2823

CONFIRMATION NO.:

4476

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